



RECEIPT

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of)	
Linda BRALY et al.)	Examiner: Not Assigned
Application No. 10/002,676)	Group Art Unit: 1765
Filed: October 31, 2001)	Docket No. LAM2P298
For: METHOD FOR PLANARIZATION)	Date: February 11, 2002
ETCH WITH IN-SITU MONITORING)	
BY INTERFEROMETRY PRIOR TO)	
RECESS ETCH)	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on February 11, 2002.

Signed: _____

Diane Schwanbeck

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents
Office of Initial Patent Examination's
Customer Service Center
Washington, D.C. 20231

Sir:

Applicants respectfully request issuance of a new Filing Receipt for the above-identified patent application that correctly lists the title of the invention. A copy of the Filing Receipt with the requested change noted thereon is attached.

Applicants submit that no fee is due because the U.S. Patent and Trademark Office caused the error for which correction is requested. Nevertheless, in the event it is determined that any fees are due, such fees may be charged to Deposit Account 50-0805 (Order No. LAM2P298).

Respectfully submitted,
MARTINE & PENILLA, LLP

Edmund H. Mizumoto
Edmund H. Mizumoto, Esq.
Reg. No. 46,938

710 Lakeway Drive, Suite 170
Sunnyvale, CA 94085
Telephone (408) 749-6900
Customer No. 25920

Attorney Docket No. LAM2P298



UNITED STATES PATENT AND TRADEMARK OFFICE

FEB 27 2002

 COMMISSIONER FOR PATENTS
 UNITED STATES PATENT AND TRADEMARK OFFICE
 WASHINGTON, D.C. 20503
 WWW.USPTO.GOV

APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/002,676	10/01/2001	1765	812	LAM2P298	13	24	3

CONFIRMATION NO. 4626

25920
 MARTINE & PENILLA, LLP
 710 LAKEWAY DRIVE
 SUITE 170
 SUNNYVALE, CA 94085

FILING RECEIPT



OC00000007226551

Date Mailed: 12/21/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Linda Braly, Albany, CA;
 Vahid Vahedi, Albany, CA;
 Erik Edelberg, San Francisco, CA;
 Alan Miller, Moraga, CA;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted 12/21/2001

Projected Publication Date: Request for Non-Publication Acknowledged

Non-Publication Request: Yes

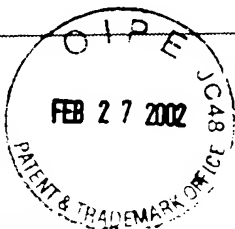
Early Publication Request: No

Title

Method and planarization etch with in-situ monitoring by interferometry prior to recess etch

Preliminary Class

438



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Title 37, Code of Federal Regulations, 5.11 & 5.15

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